

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD AND MANUFACTURE OF THIN SILICON ON INSULATOR (SOI) WITH RECESSED CHANNEL AND DEVICES MANUFACTURED THEREBY
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Application Number :

Confirmation Number:

First Named Applicant: Hui long Zhu

Attorney Docket Number: FIS920030303US1

Art Unit:

Examiner:

Search string: ( 6465311 or 6391720 or 6225173 or 4616400 or 5814544 ).pn

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6465311	2002-10-15	Shenoy			
	2	6391720	2002-05-21	Sneelal, et al.			
	3	6225173	2001-05-01	Yu			
	4	4616400	1986-10-14	Macksey, et al.			
	5	5814544	1998-09-29	Huang			

## Signature

Examiner Name	Date